

Docket No. 288321US2PCT



**MAIL STOP PCT**

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Stefan LANDIS

SERIAL NO: 10/573,156

GAU:

FILED: March 23, 2006

EXAMINER:

FOR: INFORMATION STORAGE MEDIUM AND METHOD FOR PRODUCING A STORAGE MEDIUM OF THIS TYPE

**INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

**REFERENCES**

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

**RELATED CASES**

- ☐ Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

**CERTIFICATION**

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

**DEPOSIT ACCOUNT**

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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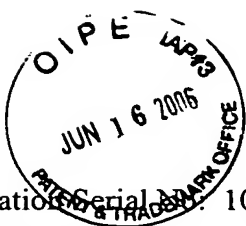
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Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 288321US2PCT		SERIAL NO. 10/573,156	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Stefan LANDIS			
				FILING DATE March 23, 2006		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	AA	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	6 602 620	8/5/2003	KIKITSU, Akira et al.			
	AB	2002/0022147	2/21/2002	TAKESHITA, Hiroto et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	03/005349	1/16/2003	WO(with English abstract & equivalent of US 2004/151947)		NO	
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW	CHOU, Stephen Y. et al., "Nanolithographically defined magnetic structures and quantum magnetic disk (invited)", J. Appl. Phys. Vol. 79, No. 8, Pages 6101-6106, 15 April 1996.					
	AX	LANDIS, S. et al., "Domain structure of magnetic layers deposited on patterned silicon", Applied Physics Letters, Vol. 75, No. 16, Pages 2473-2475, 18 October 1999.					
	AY	KRAUSS, Peter R. et al., "Fabrication of planar quantum magnetic disk structure using electron beam lithography, reactive ion etching, and chemical mechanical polishing", J. Vac. Sci. Technol. B, Vol 13, No. 6, Pages 2850-2852, 1995.					
	AZ	CHAPPERT, C. et al., "Planar Patterned Magnetic Media Obtained by ion Irradiation", Science, Vol. 280, Pages 1919-1922, 19 June 1998.				<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							



U.S. PCT Application Serial No. 10/573,156

Filed: March 23, 2006

Stefan LANDIS

Docket No. 288321 US

#### STATEMENT OF RELEVANCY

- 1) References AA - AB & AO have been cited in the International Search Report. A copy of these references is being submitted herewith.
- 2) References            have been cited in the corresponding            Search Report. A copy of these references is being submitted herewith.
- 3) References AW - AZ are discussed in the specification. A copy of these references is being submitted herewith.
- 4) References            are additional prior art known to Applicant. A copy of these references is being submitted herewith.